

Notice of References Cited	Application/Control No. 10/797,417		Applicant(s)/Patent Under Reexamination HJELMELAND, ROBERT W.	
	Examiner Nathan Danielsen		Art Unit 2627	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0015951	08-2001	Yabushita, Keiichi	369/270
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	J	US-			
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FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Official English translation of JP 01-171144
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